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SERIAL NUMBER 10/672,778	FILING OR 371(c) DATE 09/26/2003 RULE	CLASS 438	GROUP ART UNIT 2891	ATTORNEY DOCKET NO. 252016-3000	
APPLICANTS Chih-Ta Wu, Hsinchu, TAIWAN; Kuo-Yin Lin, Dali City, TAIWAN; Chia-Shiung Tsai, Hsin-Chu, TAIWAN;					
** CONTINUING DATA ***** <i>None</i>					
** FOREIGN APPLICATIONS ***** <i>None</i>					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/30/2003					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input checked="" type="checkbox"/> Met after met Allowance <i>[Signature]</i> Verified and Acknowledged <i>[Signature]</i> Examiner's Signature Initials		STATE OR COUNTRY TAIWAN	SHEETS DRAWING 3	TOTAL CLAIMS 24	INDEPENDENT CLAIMS 5
ADDRESS 000047390					
TITLE Atomic layer deposition (ALD) method with enhanced deposition rate					
FILING FEE RECEIVED 1040	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		